

DOCKET NO: 293163US26PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF

:

NOBUAKI MATSUOKA, ET AL.

: EXAMINER: HORNIG, J. G.

SERIAL NO: 10/585,975

:

FILED: JULY 13, 2006

: GROUP ART UNIT: 1792

FOR: SUBSTRATE PROCESSING
APPARATUS AND SUBSTRATE
PROCESSING METHOD

:

RESPONSE TO RESTRICTION REQUIREMENT

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Restriction Requirement dated June 5, 2009, Applicants hereby elect, *without traverse*, Group I, claims 18-28, drawn to a substrate processing apparatus. Applicants make this election based on the understanding that Applicants are not prejudiced against filing one or more divisional applications that cover the non-elected claims.

Accordingly, examination on the merits of Group I, claims 18-28 is believed to be in order and an early and favorable action is respectfully requested.

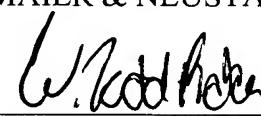
Respectfully submitted,

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